Sub-ns Microchip Lasers Technology: Overview and Progress in Health Science and Industrial Applications



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1. Company overview

- 2. Laser technology
- **3.** Added value for the process
- 4. Conclusion and perspectives





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- Founded November 1998 (Spin-off Schneider Electric/GeeO)
 Privately held
 - HQ in Meylan near Grenoble
 - Transformed business model from telecom to commercial lasers
 - > Pioneered integrated optical EDWA[™]
 - > Acquired MIT-based picolaser line in 2005 from JDSU
 - Successfully integrated acquisition
 - 6000 picolasers shipped
 - 40 people
 - Cleanroom production facility
 - Worldwide presence, US-sales office,15 distributors

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Secured Intellectual Property

Teem Photonics owns or controls the intellectual property relevant to all its products:

Exclusive IP rights on Passively Q-Switched picosecond microlaser, patent number US 5394413

- > pulse duration are under 1 ns
- > or
- > peak powers are in excess of 10 kW
- > or
- > ratio of peak power to pump DC power are above 10 000.

License agreement on high power fiber technology with IMRA



Volume capable and flexible manufacturing

High End production floor

- Class 10000 clean rooms and class 100 workstations
- Production of > 100 lasers /month
- Low fixed manufacturing costs
- Proven high production yields

Strong in-house R+D team (20% of all employees)

- Laser design
- Mechanical design
- Electronics design
- Software design

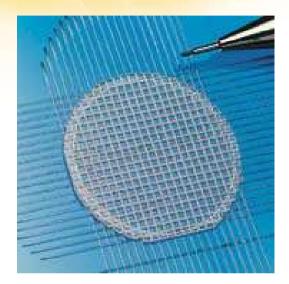


2 – Laser technology

The simplest of the Ultrafast lasers

Based on a unique technology combination:

- Microchip technology
 - > Cost-effective
 - > Reliable
 - > Compact and rugged
- Passive Q-switching
 - > Remarkable pulse characteristics
 - > Naturally good beam quality

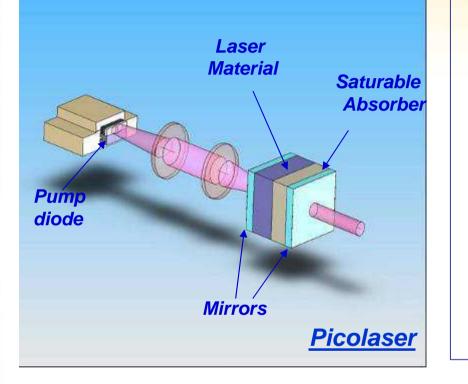




« Picolasers » = passive Q-switched microchip lasers



Picolaser principle of operation

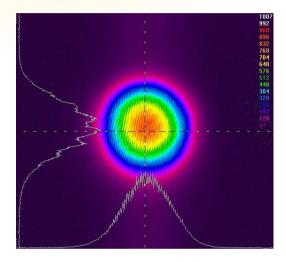


Picolasers "naturally" turns the continuous power of a semiconductor laser diode into a stream of picosecond pulses, without any external electronic devices.

- 2 main Picolaser product lines (non amplified) :
- > **Microchip** : high repetion rate, lower energy
- > **Powerchip** : high peak power, on-demand pulse emission

Picolasers performances overview

- At 1064nm, from the oscillator output :
 - > Pulse duration : down to **300ps**
 - > Peak power : up to 300kW
 - > Pulse energy : up to 100µJ
 - > Repetition rate : up to 140kHz
 - > Output power : up to 400mW
 - > Beam quality : TEM00, **M²=1.05 typ**.



- Reliability : Over 45,000 hours of operation @ 1064nm MTTF ~ 17,000,000 hours
- Some drawbacks still...
 - > Limited output power due to small cavity volume
 - > Limited process orientated controls

>

Overcoming output power limitation

Development of fiber-based MOPA architecture to reach higher power levels while valorizing Picolasers pulse characteristics and industrial grade reliability.

PicoFlash[™] series Up to >5W@1064nm Up to 40kW peak power Up to 140kHz rep.rate TEM00, M²=1.05 typical

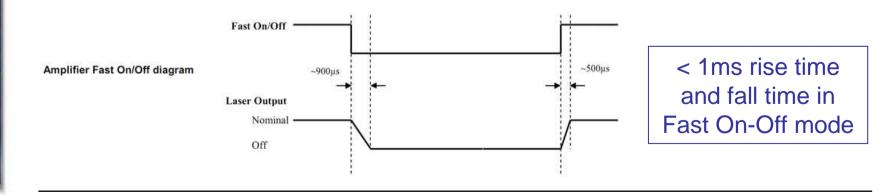
PicoSpark[™] series Up to >10W@1064nm Up to 200kW peak power Down to 750ps pulses TEM00, M²=1.05 typ.



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Making laser integration easier

- Development of OEM integration and process orientated functionnalities:
 - > Output trigger for synchronization with other equipments
 - Fast On-Off functionality dedicated to high speed processing (scanners head)
 - Real time output energy control for complex all-automated processing
 - > Output security signals for global laser safety management



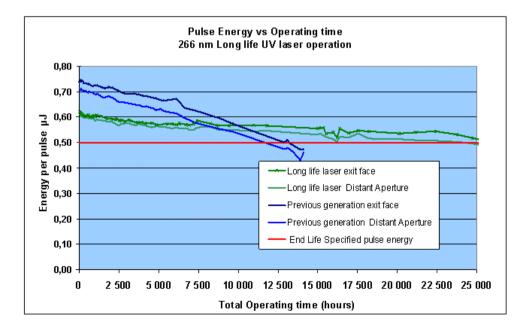
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Extending to shorter wavelentghs

Intrinsic capacity to convert efficiently to Deep UV wavelengths thanks to high peak power
 All Picolasers series available down to 266nm

>PicoFlash[™] series lasers available down to 355nm
>High peak power PicoSpark[™] lasers down to 532nm

Design and know-how combine to provide over
 25,000 hours of operation
 @ 266nm for Picolasers





3 – Added value for the process



Main features from the applicative point of view

- Laser characteristics :
 - > High peak power / Short pulse
 - > UV wavelengths
 - > Cost effective and reliable
 - Compact and air-cooled
- Favourite playgrounds :
 - > High resolution marking & scribing of virtually all materials
 - > Controlled heat-input selective ablation processes
 - > NL interaction driven processes (Supercontinuum, TPA)
 - > UV or DUV applications
 - > Industrial environment



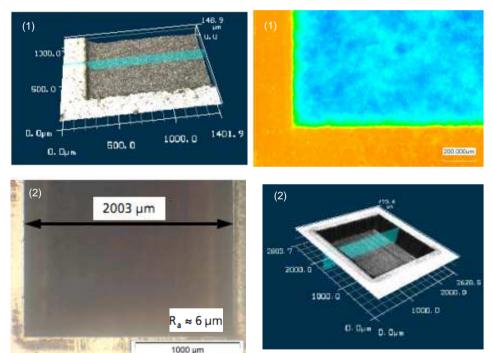
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Hard materials processing capability

Good surface quality and removal rate demonstrated for machinig oxydes, diamond-like structures, ceramics, hard metals..

Applications / Markets:

- Diamond, PCD, CVD marking and scribing
- Ivory, tooth, dental ceramics machining
- SiC drilling
- > Titanium layers selective ablation



Key parameter : high peak power

(1) Dental ceramics machining (Image courtesy of ILT, Germany)(2) PCD machining (Image courtesy of ILT, Germany)

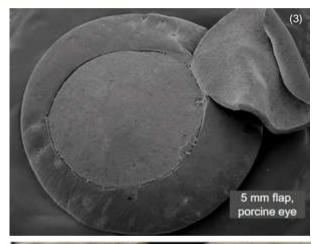
Transparent materials processing capability

Thin glass plates cutting with µm-scale chipping Bulk marking with excellent repeatability proved in various structures (crystal, glass, plastic) – No µcracks

Applications / Markets:

- Biomedical : Lasik surgery, cataract surgery
- Glass plate cutting for touchscreens or biological applications
- Bulk marking transparent plastics for traceability purpose (CR39, Polycarbonate, 1.67)
- Anti-counterfeit semi-transparent bulk marking for watch glasses

Key parameter : high peak power



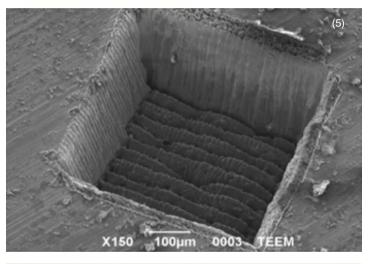


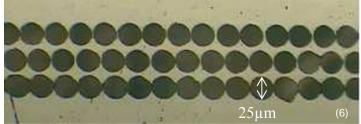
(3) Pig eye flap (Image courtesy of Luebeck university, Germany)

(4) Glass engraving (Musée de la dentelle, France)

Reflective material processing capability

- Micron-scale texturing thanks to low HAZ Marking on metals even at low energy
- Applications / Markets :
 - Surface texturing of metals parts to reduce friction (PicoSpark[™])
 - Fine scale scribing of cast or injection moulds
 - > Highly reflective metals plain marking





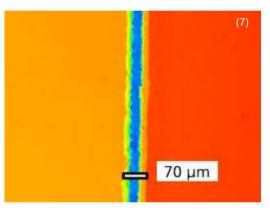
Key parameter : high peak power

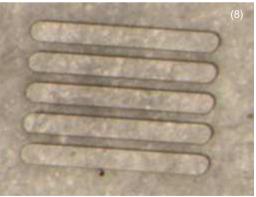
(5) Stainless steel machining(6) Single-pulse marking on aluminium (6µJ only)

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Controlled heat input micromachining

- Improved quality compared to ns lasers while conserving the economical figure
- Cost-effective alternative to ultrafast lasers or EDM
- Applications / Markets :
 - Multilayers selective removal (ITO, LEP,...)
 - Electronics : to manage increasing components density (PCB tracks correction, glue removal)
 - Polymers 'cold' processing (polyimide, PET, polyurethane,...)
 - Micromachining of thin metal foils (clock-making, micromechanics)
 - Key parameter : short pulses

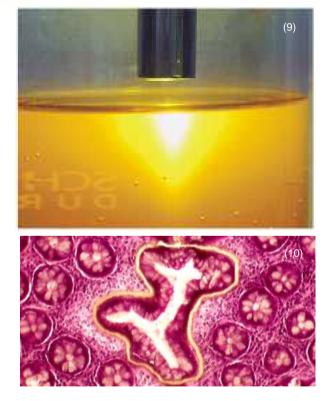




(7) Flex PCB cutting – Cut in 500µm thick polymide layer with 532nm (image courtesy of ILT, Germany)
(8) PET cutting – Cut in 15µm thick PET with 355nm (image courtesy of ILT, Germany)

Cost-effective UV solutions

- For industrial environment
- Can reduce the COO of excimer lasers based processes
 - Applications / Markets :
 - Photoluminescence (UVLED wafer testing, LIF)
 - > **Biomedical** (µ-dissection)
 - > PCB repair
 - > LCD/FPD panel repair
 - Excimer lasers replacement market



Key parameters : cost efficiency, high peak power

(9) Laser-induced fluorescence (Courtesy of Kinzle, Germany)

(10) Micro-dissection of biological tissue (Courtesy of mmi, Germany)

4 – Conclusion and perspectives



Conclusion and perspectives

Picolasers can offer picosecond class laser solutions at nanosecond economics

- Market evolutions seem to be increasingly pointing towards such laser solutions
- Qualified applications fields continuously expanding, with a wide range of segments already penetrated so far :
 - > Eye surgery with flap making
 - > Photovoltaics with CIGS cell patterning
 - > Electronics and displays with PCB, LCD and FPD repair
 - > More to come...



